

## Electronic Patent Application Fee Transmittal

Application Number:	10516457			
Filing Date:	03-Dec-2004			
Title of Invention:	Heating jacket for plasma etching reactor, and etching method using same			
First Named Inventor/Applicant Name:	Michel Puech			
Filer:	Sheldon R. Meyer/carole wong			
Attorney Docket Number:	TEGL-01250US0			

Filed as Large Entity

### U.S. National Stage under 35 USC 371 Filing Fees

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
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Basic Filing:

Pages:

Claims:

Miscellaneous-Filing:

Petition:

Patent-Appeals-and-Interference:

Post-Allowance-and-Post-Issuance:

Extension-of-Time:

Extension - 1 month with \$0 paid	1251	1	130	130
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Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
<b>Miscellaneous:</b>				
<b>Total in USD (\$)</b>				<b>130</b>